

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/552,414	MIKI ET AL.	
Examiner	Art Unit	
Kuang Y. Lin	1793	

	SEAD	CHED	
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Class	Subclass	Date	Examiner
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
PGPUB TEX	KT SEARCH	7/2/2008	LIN

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		